



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In the Application of:) Group Art Unit: Not yet assigned
Burgmair et al.) Examiner: Not yet assigned
)
Title: SENSOR AND METHOD FOR THE)
PRODUCTION THEREOF)
)
Serial No.: 10/588,559)
)
Filed: August 4, 2006) Our Docket No. 3000-0068

Springfield, Massachusetts

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Dear Sir:

Applicant(s) submits herewith Form PTO-1449 identifying patents, publications or other information of which they are aware, which they believe may be material to the examination of this application and in respect of which there may be a duty to disclose.

The filing of this Information Disclosure Statement shall not be construed as a representation that a search has been made (37 CFR 1.97(g)), an admission that the information cited is, or is considered to be, material to patentability, or that no other material information exists.

The filing of this Information Disclosure Statement shall not be construed as an admission against interest in any manner. Notice of January 9, 1992, 1135 O.G. 13-25, at 25.

I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being deposited with the United States Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Kim M. Hume
Kim M. Hume
7/3/07
Date

Application Serial No.: 10/588,559
Docket No. 3000-68

Under 37 CFR 1.97 (b)

This Information Disclosure Statement is being filed within three months of the filing date of the application, or the date of entry into the national stage of an international application, or before the mailing date of a first Office Action on the merits, whichever event occurs last, or before the mailing of a first Office Action after the filing of a Request for Continued Examination under § 1.114.

Under 37 CFR 1.97 (c)

This Information Disclosure Statement is being filed *after* three months of the filing date of this national application, or the date of entry into the national stage as set forth in §1.491 in an international application, or after the mailing date of the first Office Action on the merits, whichever event occurred last, but *before* the mailing date of either a final action under §1.113 or a notice of allowance under §1.311, whichever occurs first.

A certification as specified in 37 CFR 1.97(e) is set forth below, or
 Fee as set forth in 37 CFR 1.17(p) (\$180.00).

Under 37 CFR 1.97(d)

This Information Disclosure Statement is being filed *after* a final action under §1.113 or a notice of allowance under §1.311, whichever occurs first, but before, or simultaneously with, the payment of the issue fee. Applicant hereby petitions for the consideration of this Information Disclosure Statement, 37 CFR 1.97(d)(ii). A certification as specified in 37 CFR 1.97(e) is set forth below.

A certification as specified in 37 CFR 1.97(e) is set forth below, and
 Fee as set forth in 37 CFR 1.17(p) (\$180.00)

CERTIFICATION (37 CFR 1.97(e))

Each item of information contained in this Information Disclosure Statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Statement. A copy of the relevant search report is enclosed herewith.

No item of information contained in this Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application, and, to the knowledge of the person signing this certification after making reasonable inquiry, no item of information contained in the Information Disclosure Statement was known to any individual designated in §1.56(c) more than three months prior to the filing of this Statement.

Application Serial No.: 10/588,559
Docket No. 3000-68

Applicants respectfully request that any deficiencies in the fees be charged to Deposit Order Account No. 50-3381.

Respectfully submitted,

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3000-0068

SERIAL NO. 10/588,559

APPLICANT: Burgmair et al.

GROUP: Not yet assigned

FILING DATE: August 4, 2006

EXAMINER: Not yet assigned

INFORMATION DISCLOSURE
STATEMENT BY APPLICANT

JUL 09 2007

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
A						
B						
C						
D						
E						
F						
G						

FOREIGN PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO
H	DE 103 35 163	3/3/2005	Germany	27	414	Yes-Abstract
I	GB 2 017 400	10/3/1979	United Kingdom	27	26	
I	JP 56100350	8/12/1981	Japan	27	30	Yes-Abstract
K	JP 63171355	7/15/1988	Japan	27	30	Yes-Abstract
L	WO 85/04480	10/10/1985	WIPO	27	00	

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER INITIAL		
	M	Matsushima Toshinori et al., "Organic-inorganic field effect transistor with SnI-based perovskite channel layer using vapour phase deposition technique," Proceedings of the SPIE-The International Society for Optical Engineering, 2003, Vol. 5217. Pages 43-54 (abstract) CAPLUS [online]
	N	Sudholter, Ernst et al., "Modification of ISFETs by covalent anchoring of poly(hydroxyethylmethacrylate)hydrogel. Introduction of thermodynamically defined semiconductor-sensing membrane interface." Analytica Chimica Acta, 1990, Vol. 230, No. 1, Pages 59-65 (abstract) CAPLUS [online]
	O	
	P	
	Q	
	R	

EXAMINER

DATE CONSIDERED

EXAMINER:

Initial if citation considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.